

**Notice of References Cited**Application/Control No.  
09/212,915Applicant(s)/Patent Under  
Reexamination  
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| * |   | Document Number               | Date    | Name | Classification |  |
|---|---|-------------------------------|---------|------|----------------|--|
|   |   | Country Code-Number-Kind Code | MM-YYYY |      |                |  |
|   | A | US-                           |         |      |                |  |
|   | B | US-                           |         |      |                |  |
|   | C | US-                           |         |      |                |  |
|   | D | US-                           |         |      |                |  |
|   | E | US-                           |         |      |                |  |
|   | F | US-                           |         |      |                |  |
|   | G | US-                           |         |      |                |  |
|   | H | US-                           |         |      |                |  |
|   | I | US-                           |         |      |                |  |
|   | J | US-                           |         |      |                |  |
|   | K | US-                           |         |      |                |  |
|   | L | US-                           |         |      |                |  |
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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